



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of  
Tsung et al.

Atty. Docket: TI-30243

Serial No.: 09/921,324

Art Unit: 2823

Filed: August 2, 2001

Examiner: G. Fourson III

Title: Mass Production of Cross-Section TEM Samples by  
Focused Ion Beam Deposition and Anisotropic Etching

Amendment-B Under 37 CFR 1.116

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)  
I hereby certify that the above  
correspondence is being deposited with the  
U.S. Postal Service with sufficient postage  
for First Class mail in an envelope addressed  
to: Commissioner for Patents, Alexandria, VA  
22313-1450 on the date indicated:

12-12-03

*Jackie McBride*  
Jackie McBride

Dear Sir:

Responsive to Examiner's Office Action dated December  
3, 2003, Applicants amend the application as follows: